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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

pplicant: Shinji Maekawa

Art Unit : 2813

Serial No.:

09/724,403

Examiner: Yennhu B. Huynh

Filed

: November 27, 2000

Confirmation No.: 7575

Title

: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE WITH

TENSILE STRESS (AS AMENDED)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JUNE 19, 2003

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 15 of this paper.

TECHNOLOGY CENTER 2800